



Docket No.: 29926/39496
PATENT

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant: Hyug-Jin Kwon

Serial No.: 10/615,062

Filed: July 8, 2003

**Title: BATCH TYPE ATOMIC
LAYER DEPOSITION
APPARATUS AND IN-SITU
CLEANING METHOD THEREOF**

Group Art Unit: 1763

Examiner: S. MacArthur

I hereby certify that this paper (or fee) is being deposited with the United States Postal Service, first class postage prepaid, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

March 30, 2006

James P. Zeller
Reg. No. 28,491

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The documents listed on the enclosed Form PTO-1449 are identified pursuant to 37 CFR §§ 1.56, 1.97, and 1.98. Copies of the documents are enclosed as required.

The documents are related to Chen et al. U.S. Patent Application Publication No. 2003/0121608, which was cited in the official action dated December 30, 2005.

Relevant portions of the listed documents include Figures 1, 3, 4, and 7, which are the same in each document.

No item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in § 1.56(c) more than three months prior to the filing of the information disclosure statement.

Entry and consideration of the submitted documents are solicited.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

March 30, 2006

By: 

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Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 29926/39496	Serial No. 10/615,062
INFORMATION DISCLOSURE STATEMENT		Applicant Hyug-Jin Kwon.	
		Filing Date July 8, 2003	Group 1763

U.S. PATENT DOCUMENTS							
*Examiner Initials		Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate
		6,916,398	07/12/05	Chen et al.	156	345.33	12/21/2001
		2003/0079686	05/01/03	Chen et al.	118	715	12/21/2001

FOREIGN PATENT DOCUMENTS								
*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		

Examiner	Date Considered
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	